

IFW



**PATENT APPLICATION
Q76291**

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

In re application of

Hirofumi FUJIOKA, *et al.*

Appln. No.: 10/609,476

Group Art Unit: 2813

Confirmation No.: 2217

Examiner: Stephen W. Smoot

Filed: July 1, 2003

For: METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE

AMENDMENT UNDER 37 C.F.R. §1.111

MAIL STOP AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated August 17, 2004, please amend the above-identified application as follows on the accompanying pages.

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